



033082 M 239

PATENT

1Fa/\$

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Shuhei OGAWA, et al.

Confirmation No. 8765

U.S. Serial No.: 10/522,569

Group Art Unit: 1792

Filed: November 17, 2005

Examiner: Allan W. Olsen

For: ETCHING METHOD

THIRD INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

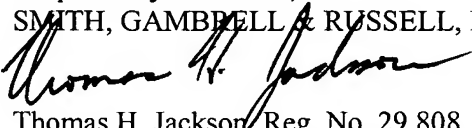
Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants enclose an Information Disclosure Citation Form (PTO-1449) which lists the reference cited in the Taiwanese Office Action dated October 1, 2008. Also, documents AA and AH are counterparts.

Each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

A Notice of Allowance on the merits has issued for this application. In accordance with the requirements of 37 C.F.R. §1.97(d), Applicants attach a check for \$180.00 in payment of the requisite fee (37 CFR §1.17(p)). It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP

By:


Thomas H. Jackson, Reg. No. 29,808
1130 Connecticut Avenue, Suite 1130
Washington, D.C. 20036
Telephone: (202) 263-4300
Fax: (202) 263-4329

December 23, 2008

12/24/2008 CNGUYEN2 00000055 10522569

01 FC:1806

100.00 0P